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BIBDATASHEET

CONFIRMATION NO. 6971

Bib Data Sheet

SERIAL NUMBER 10/748,240	FILING DATE 12/31/2003 RULE	CLASS 355	GROUP ART UNIT 2851	ATTORNEY DOCKET NO. OKI 395
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** CONTINUING DATA *****

HN

** FOREIGN APPLICATIONS *****

JAPAN 148076/2003 05/26/2003

HN

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 04/27/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and Acknowledged	Examiner's Signature	Initials	JAPAN	7	10	3

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TITLE

Self-cleaning method for semiconductor exposure apparatus

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